

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Richard M. Fastow : Group Art Unit: 2818

Application No.: 10/795,924 : Examiner: Mai Huong Tran

Filed: March 8, 2004 :

Title: SEMICONDUCTOR COMPONENT AND METHOD OF MANUFACTURE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT TRANSMITTAL

- 1. Transmitted herewith is a Response for this application.
- 2. The fee for claims has been calculated as follows:

				CL	AIMS AS	SAME	NDED		
	Claims After Amendment		No. Prev. Paid For	Present Extra		Rate - Small			Add'l <u>Fee</u>
Total	22	-	31	=	0	X	\$50.00	=	0.00
Indep.	2	-	3	=	0	X	\$200.00	=	0.00
•					Filing Fee Calculation:				<u>\$0.00</u>

3. The total fees to be paid are as follows and are enclosed payable to the

Commissioner of Patents and Trademarks:

Fee for claims adjustment: 0.00 Extension fee: 0.00 Total Fees Due: 0.00

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Serial No.: 10/795,924 Amendment Transmittal

4. Applicant believes there are no additional fees required for these filings. The Commissioner is hereby authorized to charge any deficiency to Deposit Account No. 50-2173. A duplicate copy of this Transmittal Letter is enclosed.

Respectfully submitted,

Dated: 12 October 2005 By

Rennie W. Dover, Reg. No. 36,503 THE CAVANAGH LAW FIRM 1850 N. Central Avenue, Ste. 2400

Phoenix, Arizona 85004 Telephone: (602) 322-4000

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this document (and any as referred to as being attached or enclosed) is being deposited with sufficient postage as first class mail with the United States Postal Service on October 12, 2005 and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

CAVPHXDB:1200723.1

Colleen 7 Bonner

Attorney Docket No.: H1807



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AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office action mailed July 19, 2005, please amend the application as follows: